

<b>Notice of References Cited</b>	Application/Control No. 10/659,791		Applicant(s)/Patent Under Reexamination KIVINEN, TIMO	
	Examiner Huy Q. Phan		Art Unit 2687	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,829,484 B1	12-2004	Kimoto et al.	455/457
*	B	US-2002/0087542 A1	07-2002	Itabashi, Tatsuo	707/9
*	C	US-2002/0004398	01-2002	Ogino et al.	455/456
*	D	US-6,693,951 B1	02-2004	Gilhousen et al.	375/130
*	E	US-5,946,618 A	08-1999	Agre et al.	455/428
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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